INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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First Named Inventor Takada et al.

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(Multiple sheets used when necessary)
SHEET 1 OF 1

			U.S. PATENT I	DOCUMENTS	
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	1	CRIVELLO, JAMES V. Possibilities for Photoimaging Using Onium Salts, <i>Polymer Engineering and Science</i> , Mid-December, Vol. 23, No. 17, pages 953-956, 1983.				
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